



Application No. 09/461,158
Amendment. dated December 19, 2003
Reply to Office Action of September 25, 2003

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Attorney's Docket No.: 42390.P6958

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Anne E. Miller et al.

U.S. Serial No: 09/461,158

Examiner: Chen, Kin Chan

Filed: December 14, 1999

Art Unit: 1765

For: HIGH PH SLURRY FOR
CHEMICAL MECHANICAL
POLISHING OF COPPER

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Office Action mailed September 25, 2003. Applicant respectfully requests the Examiner to consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to Mail Stop Non-Fee Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

on December 19, 2003
Date of Deposit

Claire Wallters
Name of Person Mailing Correspondence

Claire Wallters
Signature

12/19/2003
Date